

# 91705  
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R. D. G.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OCT 16 2002  
PATENT & TRADEMARK OFFICE

Inventors:	Jaime Poris;		
Assignee:	Nanometrics Incorporated		
Title:	Method of Measuring Dishing		
Serial No.:	09/578,798	Filing Date:	May 23, 2000
Examiner:	William C. Choi	Group Art Unit:	2873
Docket No.:	NAN040 US	Confirmation No.:	5190

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Santa Clara, California  
October 16, 2002

COMMISSIONER FOR PATENTS  
Washington, D. C. 20231

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §1.97(c)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the documents listed on the accompanying Form PTO-1449. A copy of the documents is also submitted herewith. The Examiner is requested to make these documents of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(c) as it is after receipt of a first Office Action on the merits but before mailing of a final Action or Notice of Allowance. Accordingly, a fee is required pursuant to 37 CFR §1.17(p). A Fee Transmittal form (PTO/SB/17) is attached to this submission.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement under 37 C.F.R. §1.555 is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the

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like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Via Express Mail Label No.  
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Respectfully submitted,



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